

KIC to Exhibit Smart Thermal Process Solutions at SMTA Dallas Expo & Forum

SAN DIEGO, CA — KIC, a global leader in thermal process control solutions for electronics manufacturing, will exhibit at the SMTA Dallas Expo & Forum on April 7, showcasing technologies that transform thermal data into actionable insight.



KIC’s “Heat to Data” approach turns captured process information into actionable data, enabling manufacturers to improve process control, consistency, and throughput.

Featured solutions include **HeatMap™** oven monitoring, which provides continuous visibility into oven performance between profiles, helping detect thermal drift and maintain stable processes without interrupting production.

KIC will also highlight its automatic profiling solutions, which is the direction the industry is moving toward.

This provides continuous reflow profile monitoring, ensuring consistent product quality and replacing a once tedious, operator-dependent process (manual profiling) with automated, data-driven process control.

For more information, visit www.kicthermal.com or contact KIC at 858-673-6050.

About: KIC is a leading provider of thermal profiling and process control solutions. With a commitment to innovation and quality, KIC delivers cutting-edge technologies that help manufacturers enhance production efficiency, product quality, and sustainability.

KIC-Making Ovens Smarter